



PATENT APPLICATION

In re the Application of

Yasuhiro OMURA

Group Art Unit: 2882

Application No.: 10/587,254

Examiner: C. KREUTZER

Filed: June 1, 2007

Docket No.: 128834

For: OPTICAL SYSTEM, EXPOSURE SYSTEM, AND EXPOSURE METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

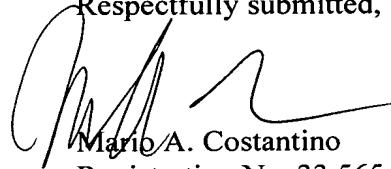
Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed with a Request for Continued Examination. No certification or fee is required.
- 2. Office Actions were issued in related foreign or international applications. Original and English language versions of the Office Actions are attached as References 233, 234, 236, 244, 246, 251, 252, 254-258, 267-274, 276, 279 (English version only), 280 (English version only), 281, 289, 293-295, and 298.
- 11. Search reports and Written Opinions were issued in related foreign or international applications. Originals and English language versions of the search reports and Written Opinions are attached as References 231, 245, 263, 264, 275, 278, 286, 287, 297, and 299.
- 3. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- 4. An English language Abstract of one or more non-English language reference is included. See References 138, 139, 142, 148-203, 205-208, 210-212, 214, 215, 217-219, and 221-223.

- 5. A complete English language translation of one or more non-English language reference is attached. See References 221-223.
- 6. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See References 148, 149, 151-153, 155-159, 161, 163, 166-168, 175, 177, 181, 185-196, and 208.
- 7. One or more co-pending U.S. patent application is identified on the attached Form PTO 1449. The Examiner is respectfully requested to consider each cited application and the art cited therein during examination of the present application. See References 118-137 and 300.
- 8. Reference 24 corresponds to Reference 208. Reference 76 corresponds to Reference 224. References 110 and 111 correspond to References 189 and 190, respectively.

Respectfully submitted,



Mario A. Costantino
Registration No. 33,565

Michelle K. Windom
Registration No. 65,466

MAC:MQW/mjb

Date: May 6, 2011

OLIFF & BERRIDGE, PLC
P.O. Box 320850
Alexandria, Virginia 22320-4850
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry of this filing; Charge any fee due to our Deposit Account No. 15-0461
